



Gases and Facilities Japan Joint TC Chapter Meeting

Japan Standards Spring Meetings 2025

Friday, April 25, 2025

Boad Room, SEMI Japan, Tokyo Japan/ Official Virtual TC Chapter Meeting (Hybrid)

14:00-17:00 (JST)

AGENDA

1 Welcome/Call to Order

- 1.1 Introductions
- 1.2 Required Elements (Membership Requirements, Antitrust and Intellectual Property Reminders, and Effective Meeting Guidelines)
- 1.3 Agenda Review

2 Review of Previous Meeting Minutes

3 Liaison Report

- 3.1 Japan Regional Standards Committee (JRSC)
- 3.2 Global Coordinating Subcommittee (GCS)
- 3.3 Europe TC Chapter
- 3.4 North America TC Chapter
- 3.5 Korea TC Chapter

4 Staff Report

5 Ballot Review

- 5.1 Doc.#7297 — Revision to SEMI E137-0705 (Reapproved 0118), Guide for Final Assembly, Packaging, Transportation, Unpacking, and Relocation of Semiconductor Manufacturing Equipment

6 20Subcommittee & Task Force Reports

- 6.1 Gases Japan TC Chapter
 - 6.1.1 5-Year-Review Task Force
- 6.2 Facilities Japan TC Chapter
 - 6.2.1 F1 Revision Task Force
 - 6.2.2 E137 Revision Task Force
 - 6.2.3 5-Year-Review Task Force

7 Old Business

- 7.1 Project Period Review
- 7.2 5-Year-Review

8 New Business

9 Action Item Review

9.1 Open Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
G+F_20241024-01	SEMI Staff	To submit the results of Doc.#7205A and 7206A ballot review to the ISC A&R for procedural review.
G+F_20241024-02	5-year Review TF	To prepare PCR to make an editorial change to SEMI F44. (Refer to New Business section.)
G+F_20241024-03	E137 Revision TF	To submit Doc.#7292, Revision to E137-0705 (Reapproved 0118), Guide for Final Assembly, Packaging, Transportation, Unpacking, and Relocation of Semiconductor Manufacturing Equipment for Cycle 2, 2025.

9.2 New Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>

10 Next Meeting and Adjournment

- 10.1 The next meeting is scheduled for <date> at <event/location>.